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APPLICANTS

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** CONTINUING DATA *****

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** FOREIGN APPLICATIONS *****

JAPAN 2002-206789 07/16/2002

RM

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** 10/14/2003

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged Examiner's Signature: [Signature] Initials: [Initials]	STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 4
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ADDRESS

000513

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20006-1021

TITLE

Method and apparatus for quantitative quality inspection of substrate such as wafer

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